

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 1821  
Mitsuhiro OKUNE et al. : Attorney Docket No. 2006\_0772A  
Serial No. 10/581,256 : Group Art Unit 1792  
Filed May 31, 2006 : Examiner Mahmoud Dahimene  
PLASMA ETCHING METHOD : Mail Stop AF

DO NOT ENTER

3/27/09  
MDT

AMENDMENT UNDER 37 CFR § 1.116

OIC TO ENTER AE  
4/24/09  
Per RCC  
4/23/09

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action mailed December 24, 2008, please amend the above-identified application as follows.

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